

Notice of References Cited	Application/Control No. 10/687,743	Applicant(s)/Patent Under Reexamination SAKAGUCHI ET AL.	
	Examiner Thao X Le	Art Unit 2814	Page 1 of 1

U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
	A	US-6,342,433	01-2002	Ohmi et al.	438/455
	B	US-6,475,820	11-2002	Ohmi et al.	156/239 ✓
	C	US-			
	D	US-			
	E	US-			
	F	US-			
	G	US-			
	H	US-			
	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

FOREIGN PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N	JP 11-317509	02-1999	Japan	Omi Kazuaki	H01L 27/12
	O	EP 1061566	06-2000	Europe	Takao, Yonehara	H01L 21/304 ✓
	P					
	Q					
	R					
	S					
	T					

NON-PATENT DOCUMENTS

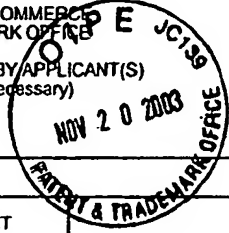
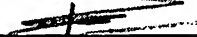
*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	
	V	
	W	
	X	

*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.

FORM PTO 1449 (modified) U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE LIST OF REFERENCES CITED BY APPLICANT(S) (Use several sheets if necessary)				ATTY DOCKET NO. 00862.022497.1		APPLICATION NO. 10/687,743	
<div style="border: 1px solid black; border-radius: 50%; padding: 10px; display: inline-block;"> MAY 25 2004 U.S. PATENT & TRADEMARK OFFICE </div>				APPLICANT KIYOFUMI SAKAGUCHI, ET AL.			
				FILING DATE October 20, 2003		GROUP N.Y.A.	
U.S. PATENT DOCUMENTS							
*EXAMINER INITIAL		DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
TL		6,682,963	01/27/04	Ishikawa	438	149	
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		6,627,487	09/30/03	Zhang	438	166	
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		DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION YES/NO/ OR ABSTRACT
OTHER DOCUMENT(S) (Including Author, Title, Date, Pertinent Pages, Etc.)							
EXAMINER		DATE CONSIDERED 09/23/04					

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	5,256,562	10/26/93	Vu et al.	437	86	
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		GROUP NYA	

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